

Intelligent Design

XEI Scientific, Inc introduces our new line of Remote Plasma Cleaners for removal of hydrocarbon contamination in SEMS and FIBS, Tabletop model Evactron® 25 and Rackmounted Evactron® 45.



Tabletop Model Evactron® 25 De-Contaminator



Rackmounted Evactron® 45 De-Contaminator

At XEI Scientific we're at the forefront of the 21st Century in downstream remote plasma cleaning with our new models, the Evactron® 25 and 45. Evactron® D-C works by using oxygen radicals to remove atmospheric molecular contamination, oils and other hydrocarbons through chemical ashing. Rackmounted Evactron® 45 fits perfectly amidst the rest other scanning electron microscope SEM or focused ion beam FIB instrumentation. Evactron® 25 is a tabletop version that can sit on your desk. Our new line of Evactron® models for SEM and FIB chamber cleaning have

advanced microprocessor control allowing the operator to pre-set cleaning time, pressure and power. New plasma detection logic makes sure that the plasma has ignited and is producing oxygen radicals. An operational log keeps a record of your cleaning and helps with troubleshooting. All these features will increase the efficiency of cleaning, so you cleaner chambers and great pictures. New user friendly Evactrons® optimize remote downstream plasma cleaning perfectly for your needs.



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